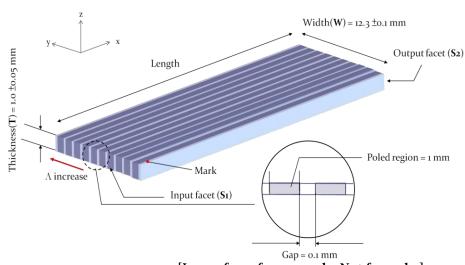


Periodically Poled Lithium Niobate (PPLN) Chip: SHNIR-MF

- Chip Lay-Out



[Image for reference only. Not for scale.]

Items	Properties	Inspection
Material	5 mol.% MgO:LN	NA
Period (Λ,μm)	18.45, 18.65, 18.85, 19.05, 19.25, 19.45, 19.65, 19.85, 20.05, 20.25	Microscope
Main Function	Second Harmonic Generation	NA
Parallelism/Perpendicularity	≤5'/21'	Autocollimator
Flatness	≤λ/6 (λ=633nm)	Interferometer
Scratch/Dig	≤20/10	Microscope
Optical coating (S1/S2 facets)	S1/S2 @750-810(R<0.5%) /1500-1620(R<0.5%) nm	Spectral Analyzer
Aperture Size	12.3 X 1.0 mm ² (W XT)	Cutting Machine
Available Length	10/25/50 ± 0.2 mm	
Channel Clear Aperture	≥80% (T), ≥90% (W)	NA

- Phase Matching Tuning Curve

